

Total reflection of X-rays

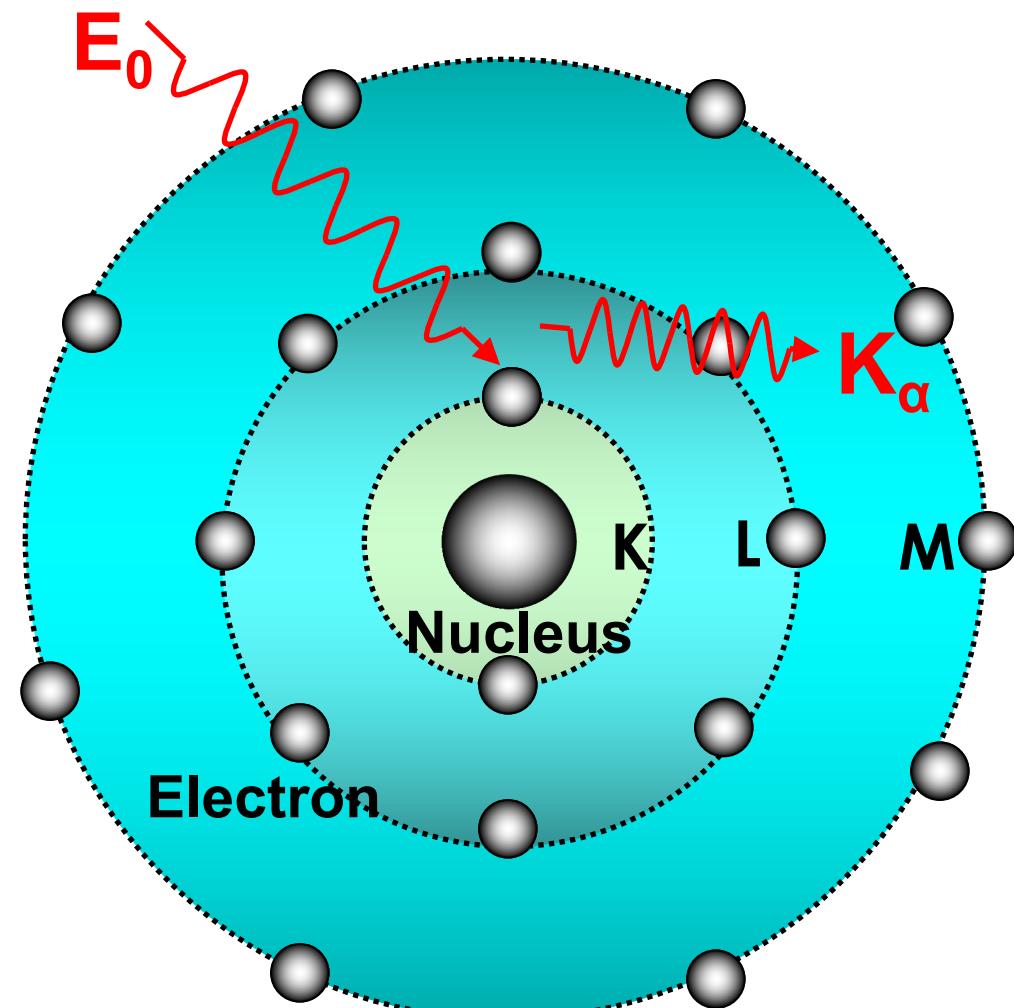
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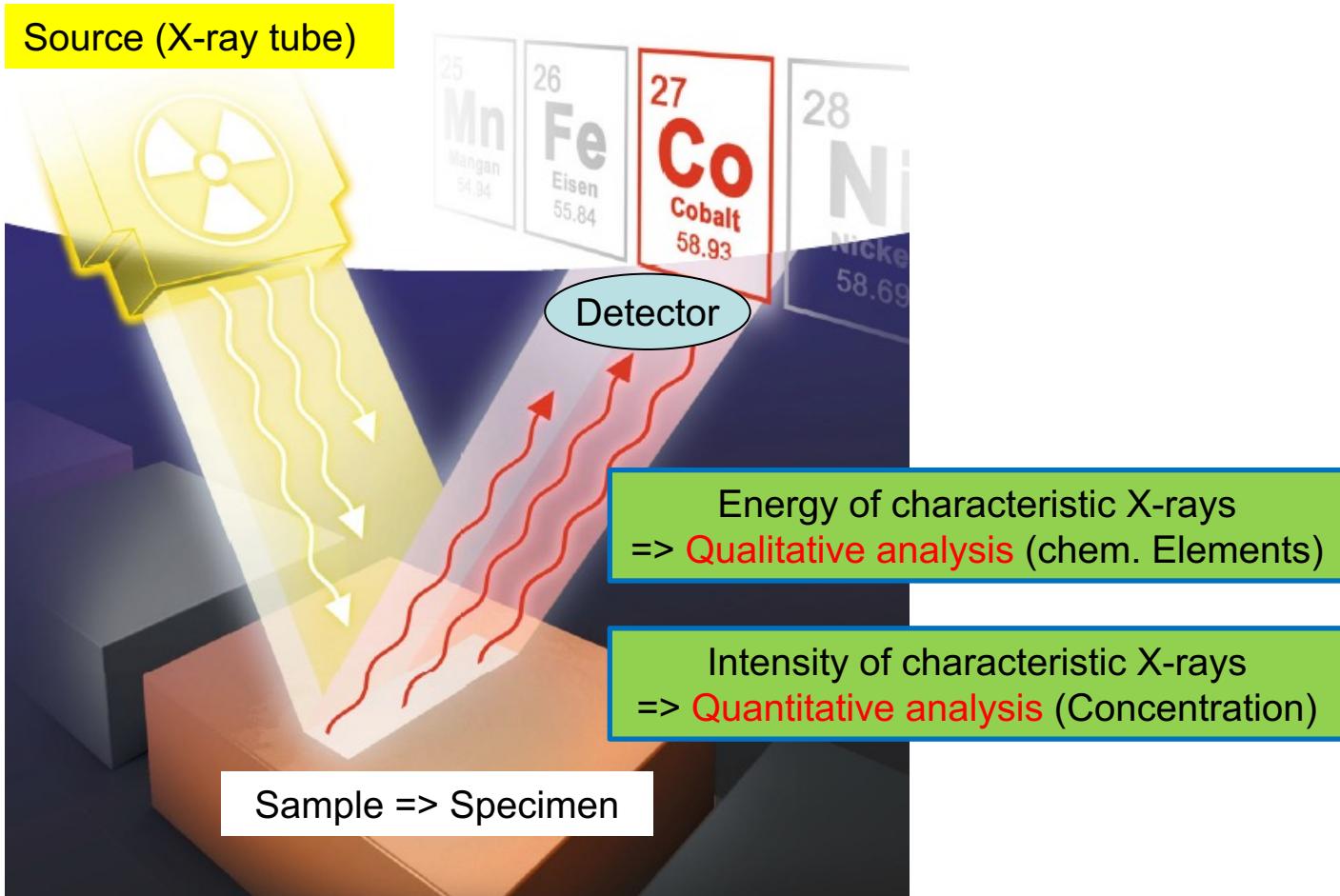
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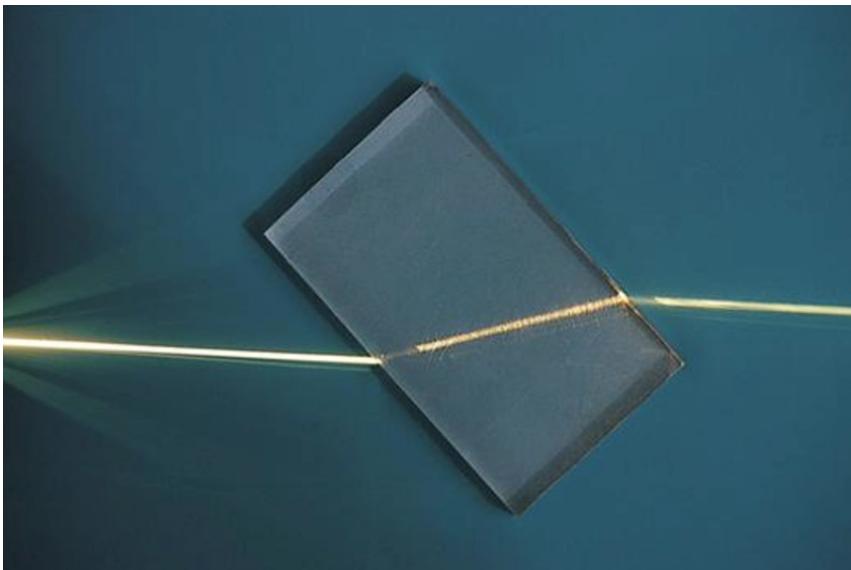
Working principle:

- 1) Photo-ionization of atomic bound electrons (K, L, M)
- 2) emission of photo-electron
- 3) => electron from higher shell fills this position
- 4) Emission of element "characteristic" fluorescence X-rays

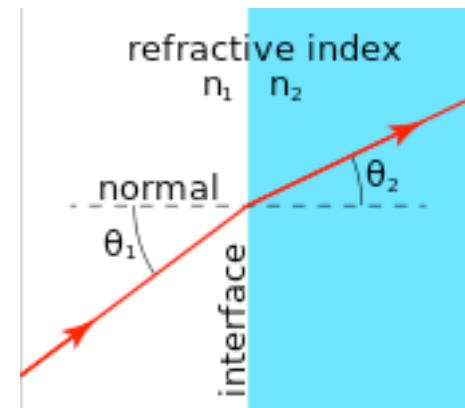


Energy E_0 must be adequate to expel bound electrons:
 $E_0 >$ Binding energy of respective shell (K, L, M)



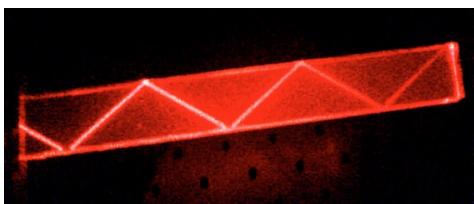
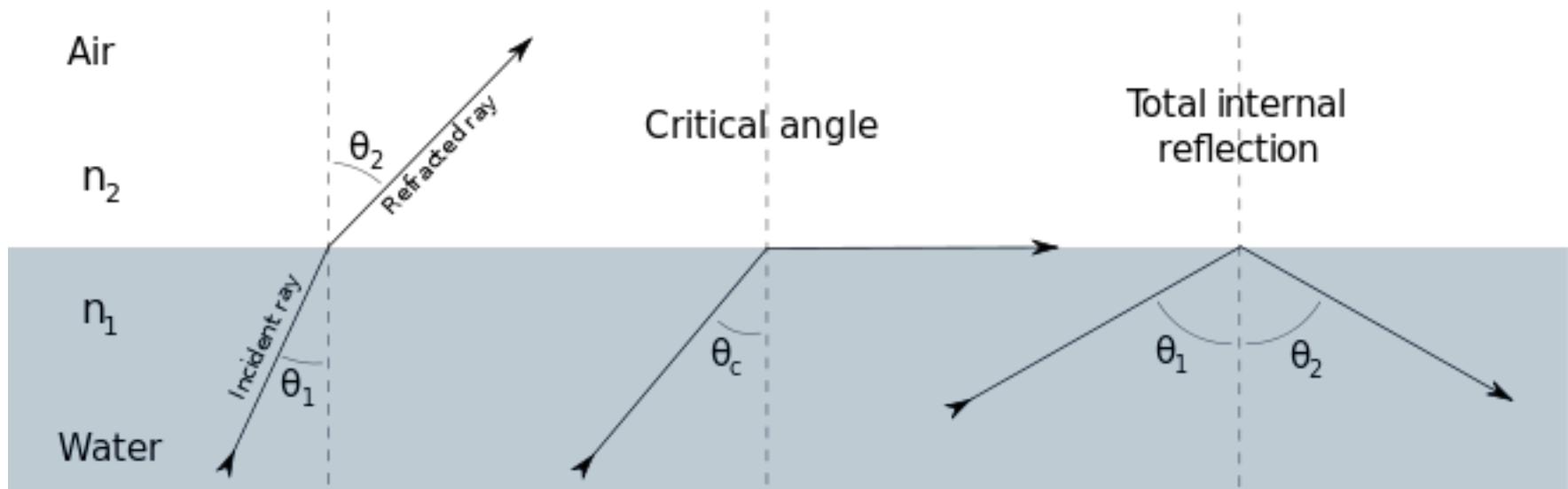


A ray of light being refracted in a plastic block.



$$\frac{\sin \theta_2}{\sin \theta_1} = \frac{v_2}{v_1} = \frac{n_1}{n_2}$$

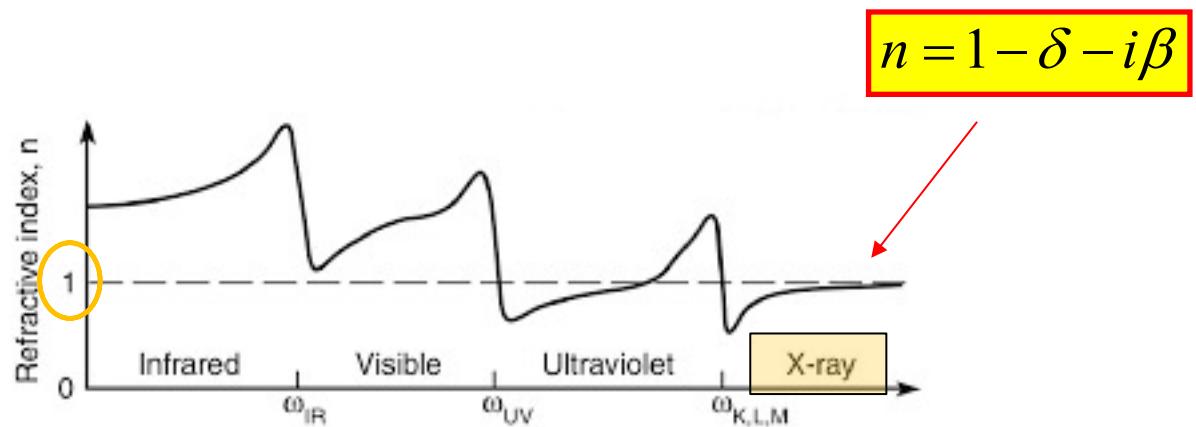
Refraction of a light ray.



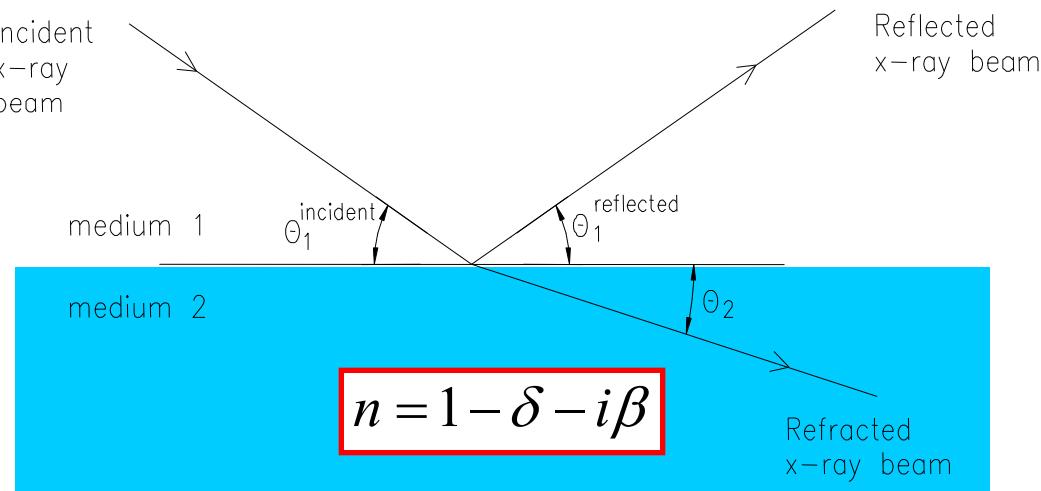
$$\frac{\sin \theta_2}{\sin \theta_1} = \frac{v_2}{v_1} = \frac{n_1}{n_2}$$

$$n_1 > 1$$
$$n_2 = 1$$

Refraction of light at the **interface** between two media,
including total **internal** reflection.



$n < 1$ for X-rays
e.g.: 0.999995



$$n = 1 - \delta - i\beta$$

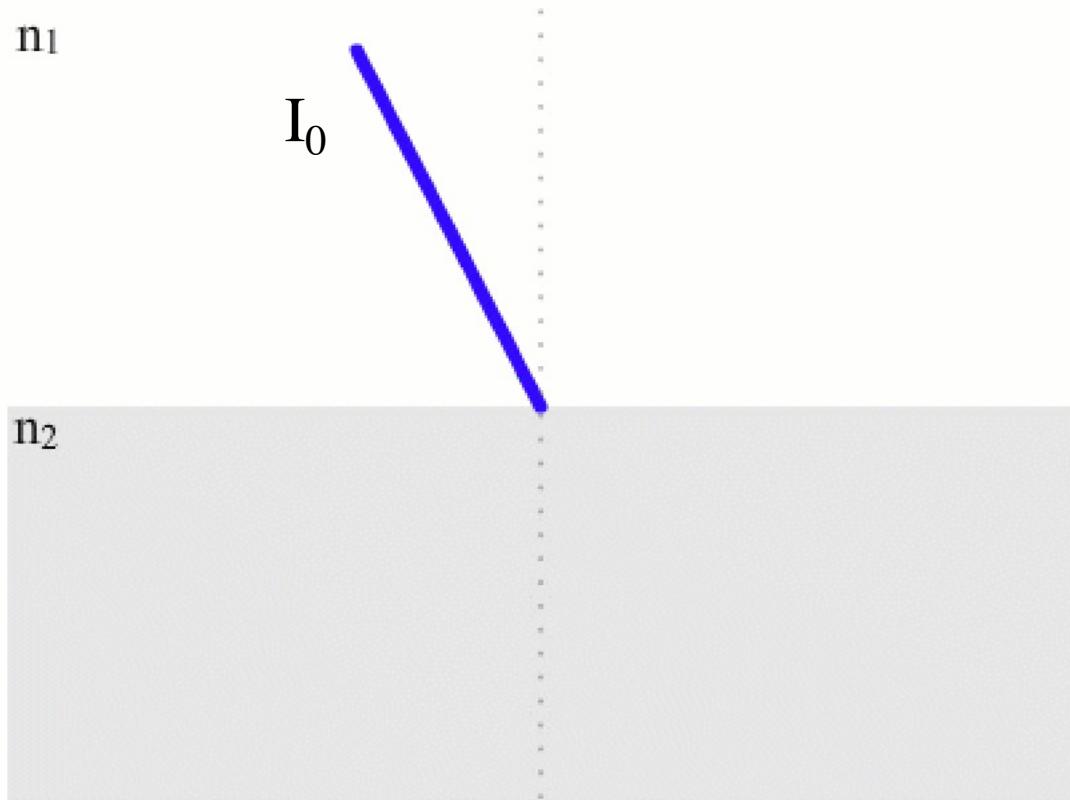
X-ray range:

$\delta \sim 10^{-6}$... dispersion (coherent scatter)

$\beta \sim 10^{-8}$... absorption

$$\varphi_{Si}^{crit}(\text{mrad}) \approx \sqrt{2 \cdot \delta} \approx \frac{32.2}{E_0(\text{keV})}$$

Quartz reflector, $E_0 = 17.5 \text{ keV}$: $\approx 0.1^\circ \approx 1.75 \text{ mrad}$

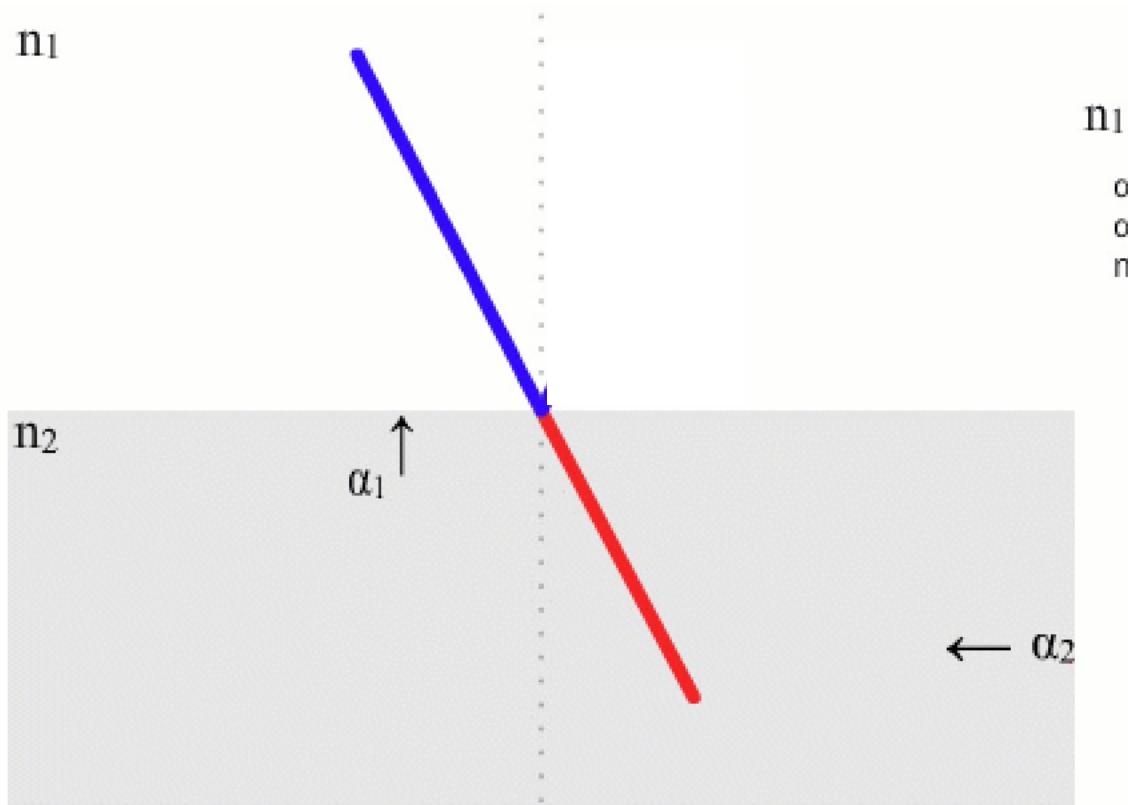


$$n_1 \cos \alpha_1 = n_2 \cos \alpha_2$$

α_1 : angle of incidence
 α_2 : angle of refraction
 n_1, n_2 : refraction index

$n_1 = 1$
$n_2 = 0.98$
$\alpha_1 = 63^\circ$
$\alpha_2 = 62^\circ$

If the beam hits the boundary surface of a second medium, like a surface of a solid object, it will be deflected from the original direction.



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n_1

n_2



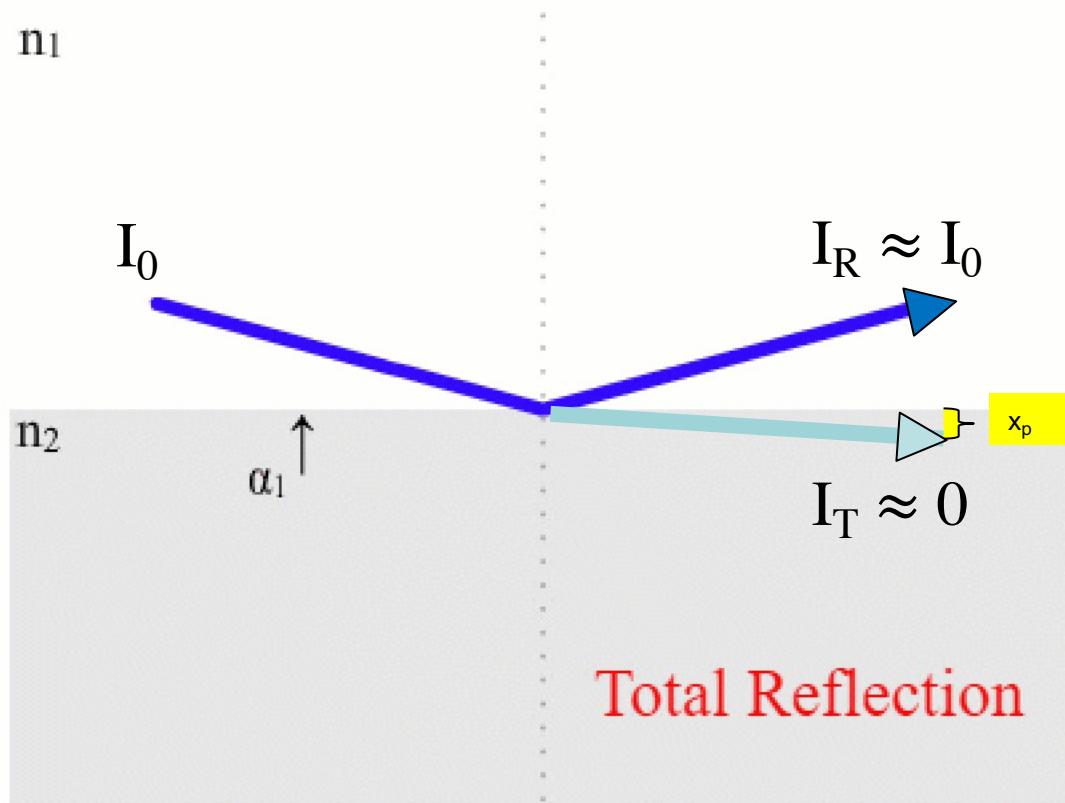
Total Reflection

$$n_1 \cos \alpha_1 = n_2 \cos \alpha_2$$

α_1 : angle of incidence
 α_2 : angle of refraction
 n_1, n_2 : refraction index

$n_1 = 1$
$n_2 = 0.94$
$\overline{\angle}$
$\alpha_1 = 15$
$\overline{\angle}$
$\alpha_2 = TR$

If the beam hits the boundary surface of a second medium, like a surface of a solid object, it will be deflected from the original direction.



$n_1 = 1$
$n_2 = 0.94$

$\alpha_1 = 15^\circ$

$\alpha_2 = TR$

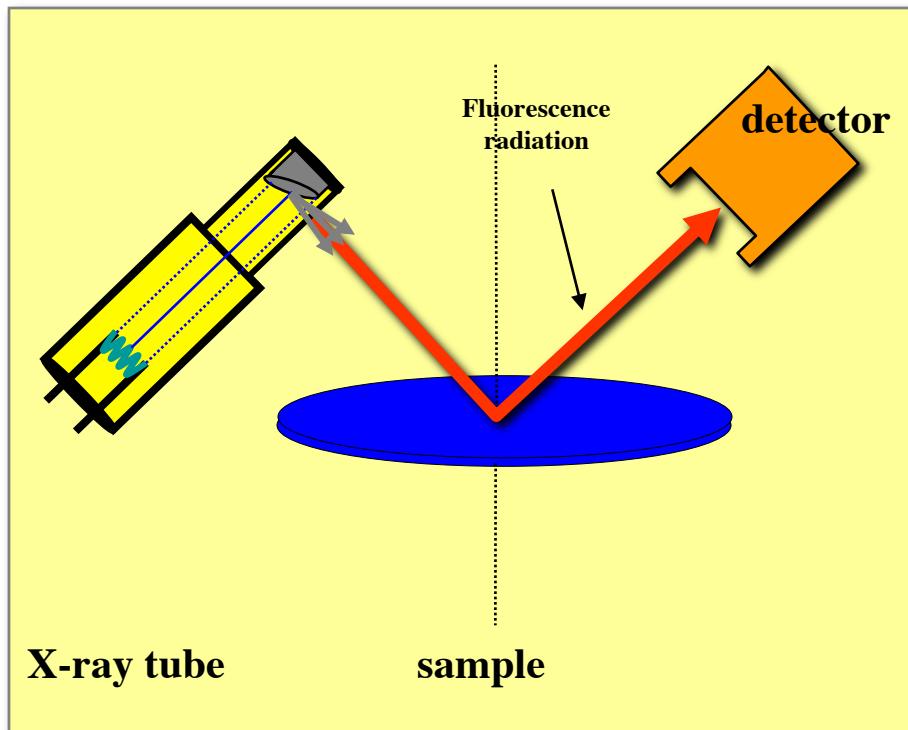
If the beam hits the boundary surface of a second medium, like a surface of a solid object, it will be deflected from the original direction.

x_p ... penetration depth

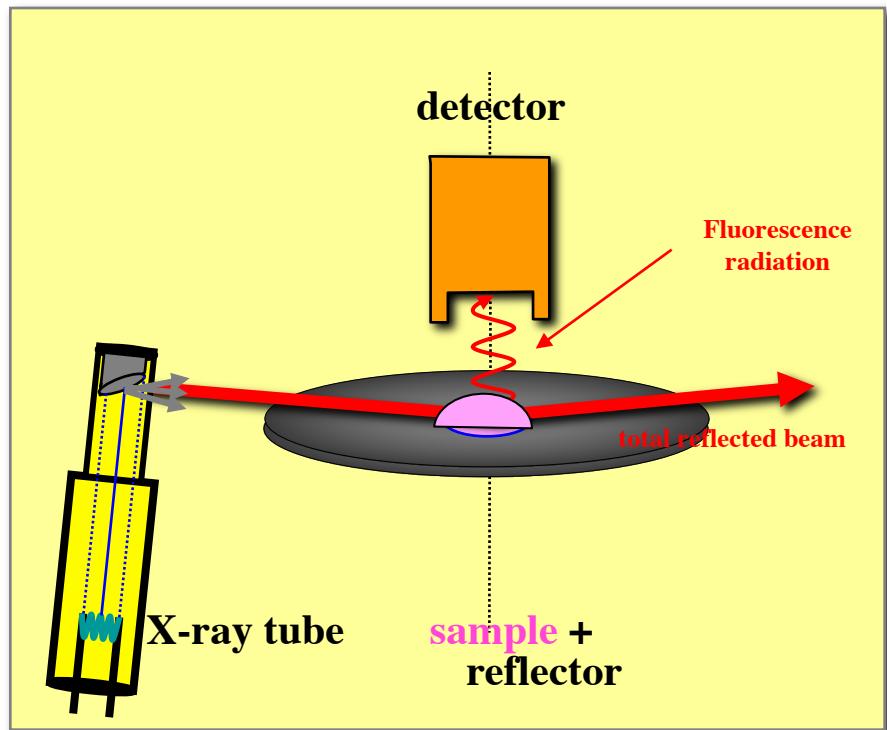
Total reflection X-ray Fluorescence Analysis

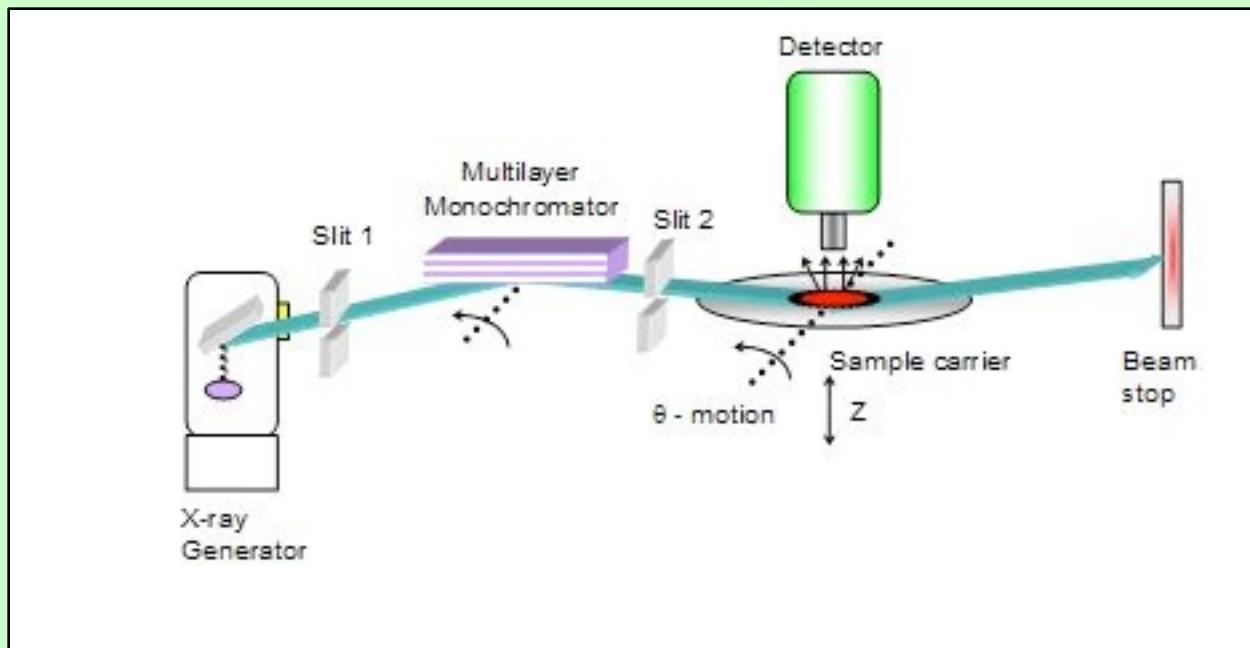
TXRF

X-Ray Fluorescence



Total-reflection X-Ray Fluorescence





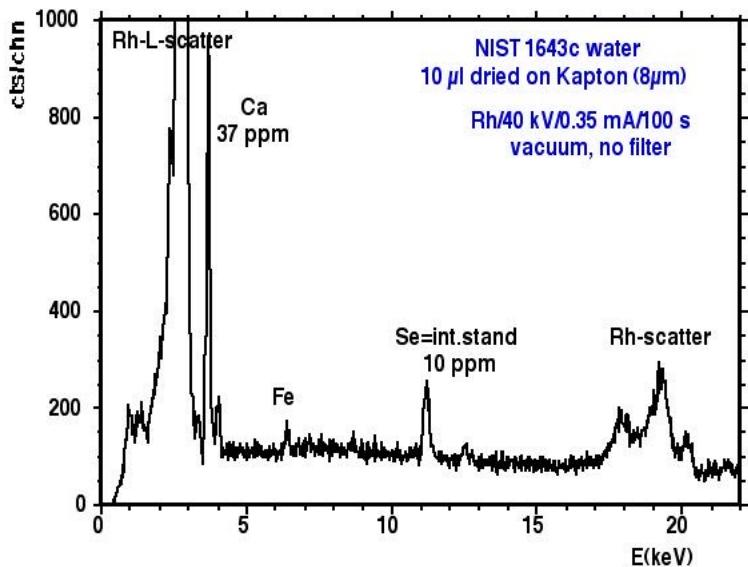
- X-ray tube
- Monochromator
- Sample carrier, adjustment
- Detector



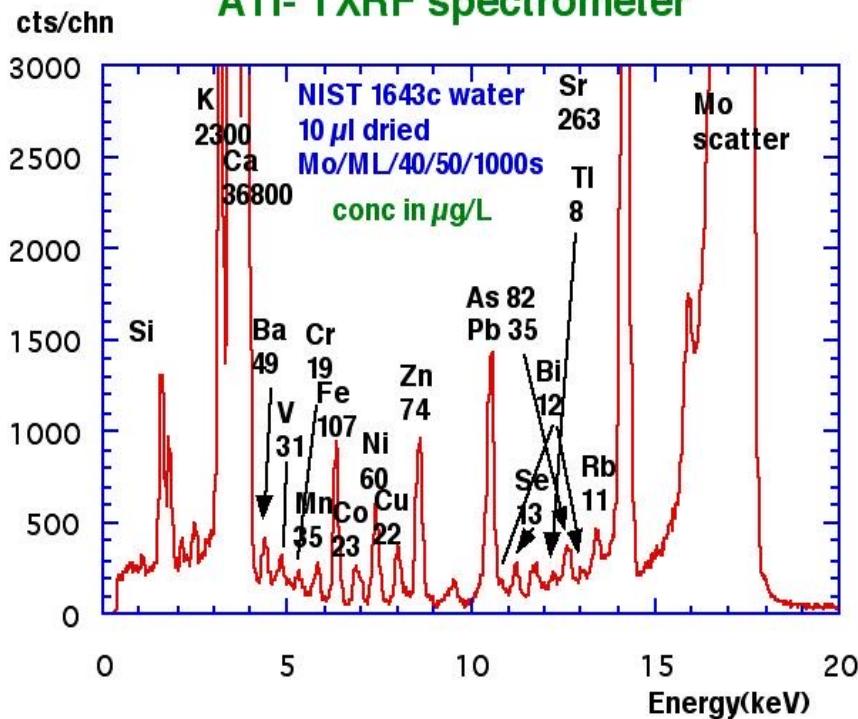
- fill sample in micro tube
 - add internal standard
 - homogenize
- pipette on carrier

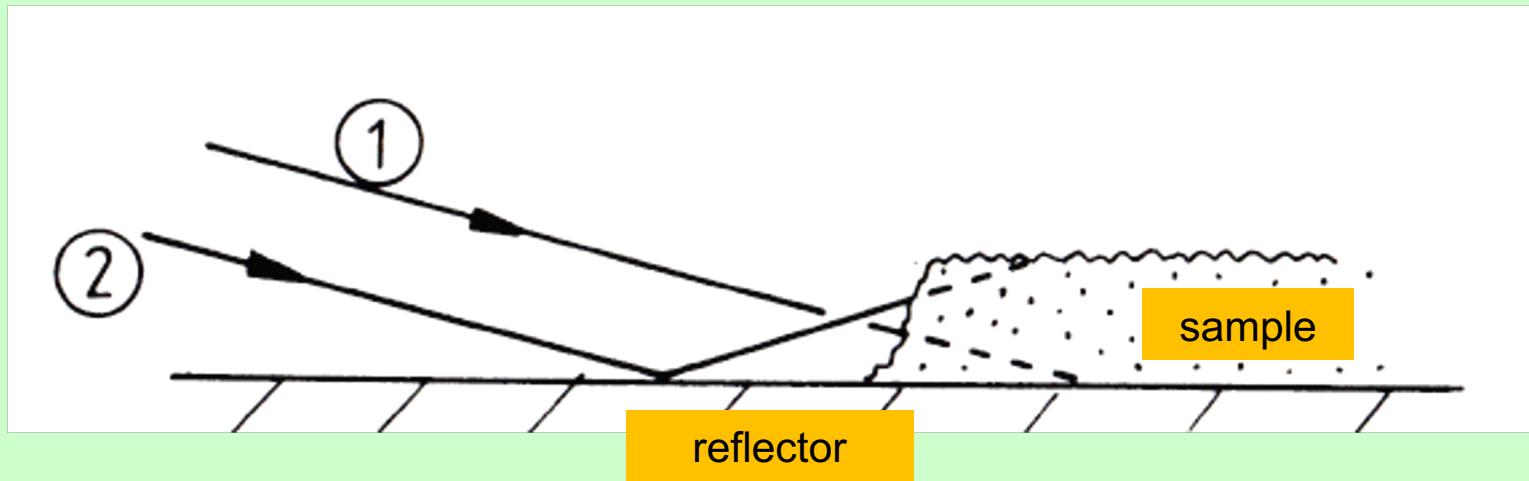
Fig. 6.2.1 NIST TN5000

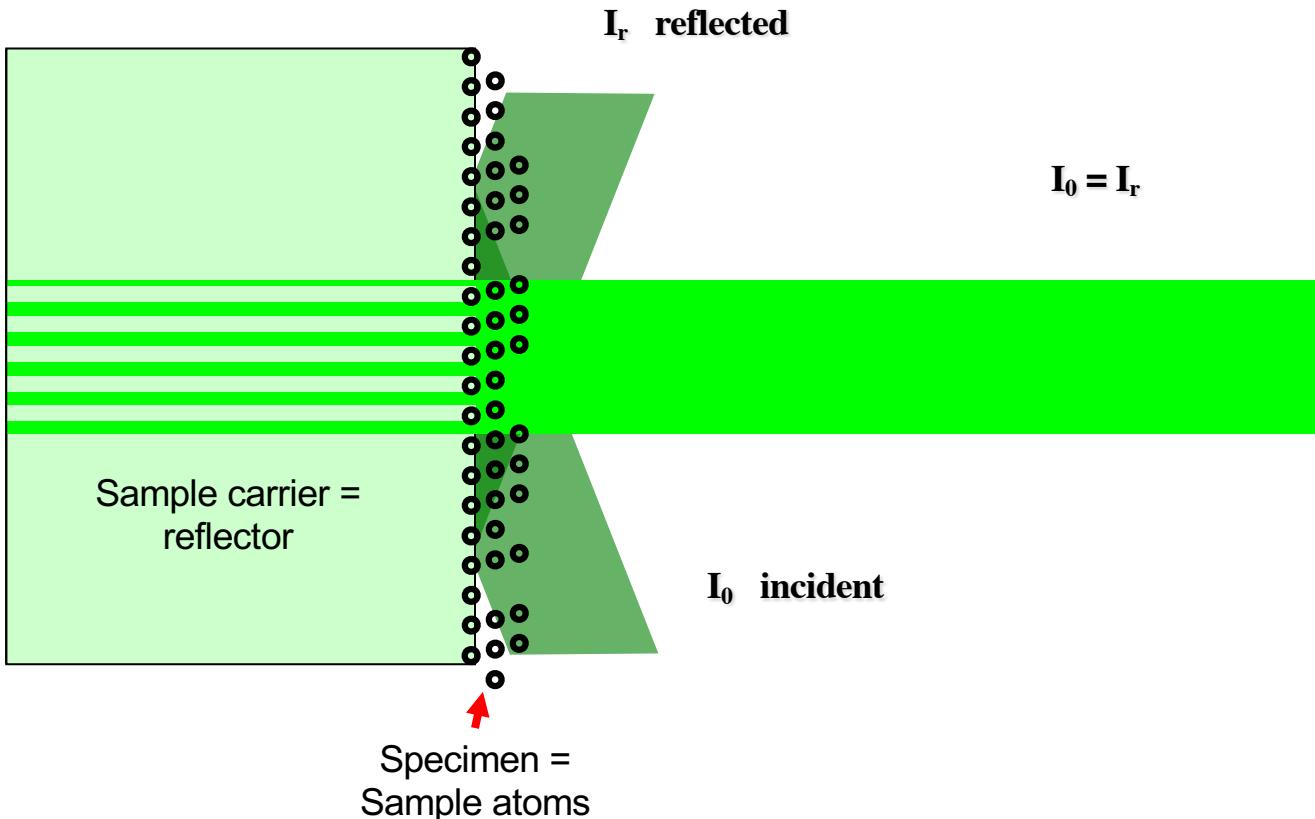
Standard EDXRF spectrometer TN5000

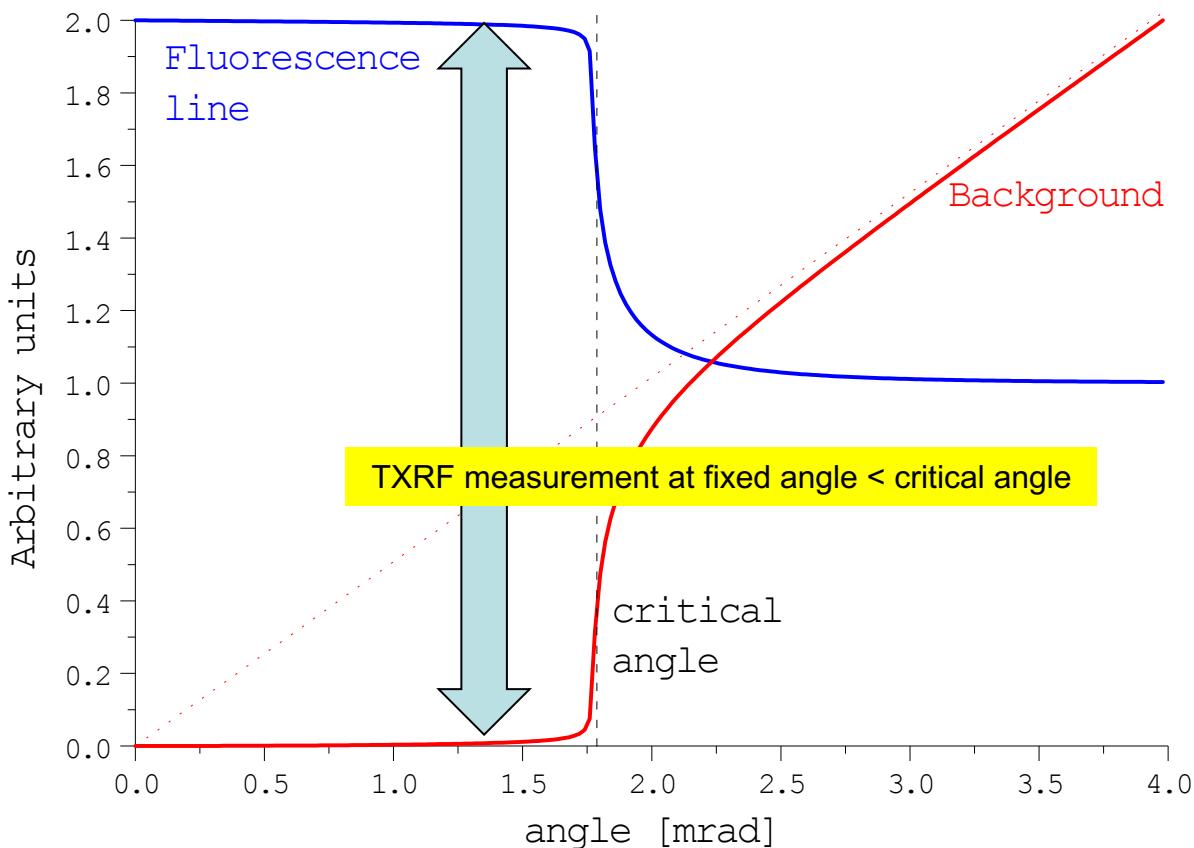


ATI- TXRF spectrometer







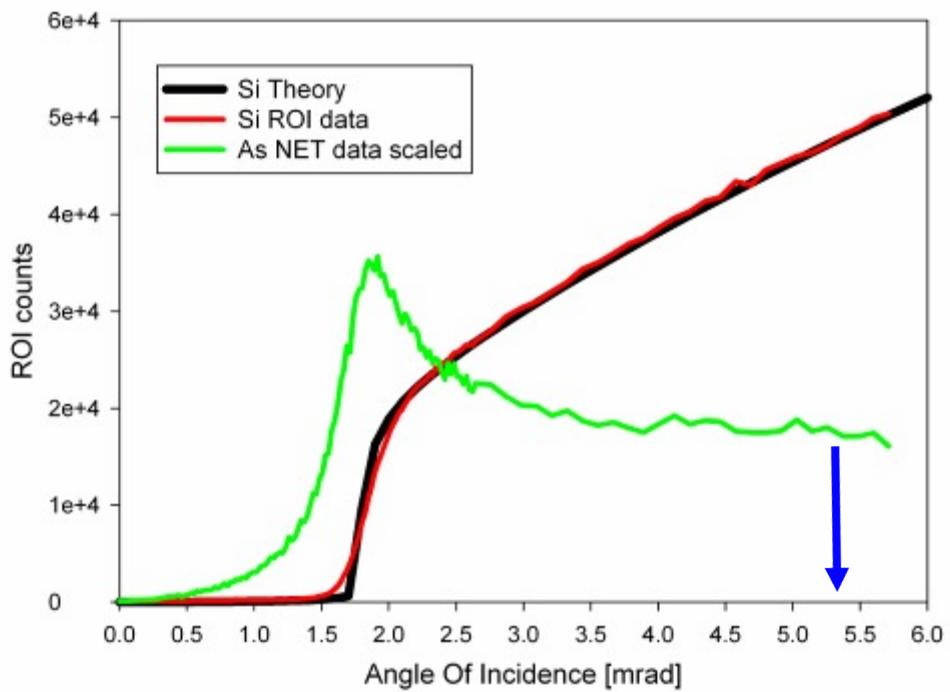
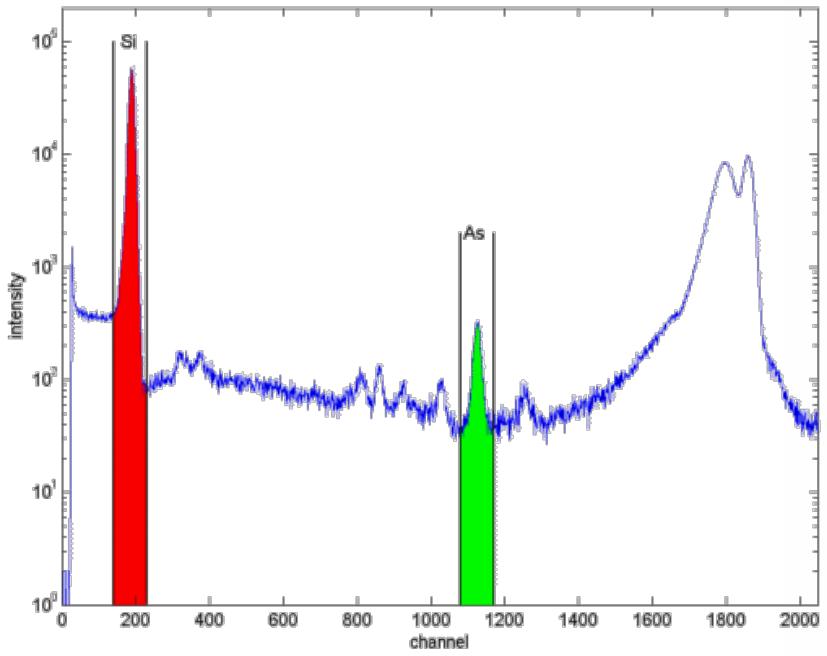


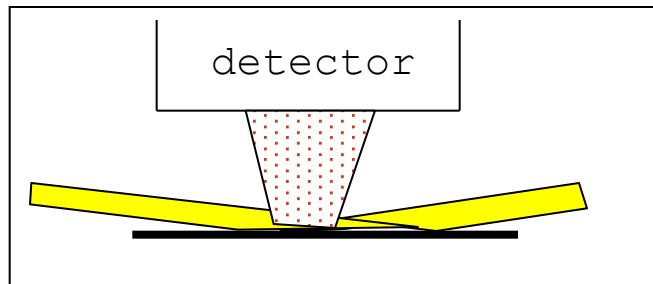
Line intensity
 $I_L \propto (1 + R)$

Background
 $I_B \propto (1 - R) \cdot \sin\phi$

Quartz reflector, Mo-K α radiation

as function of the angle of incidence



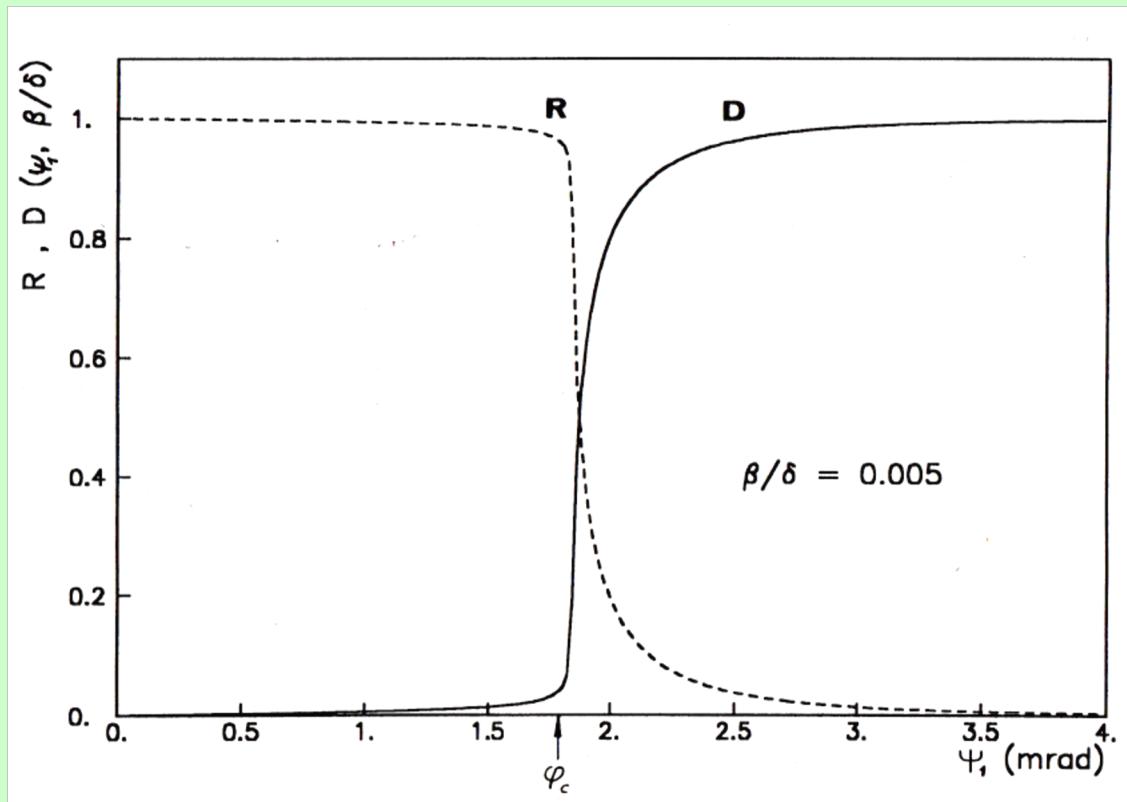


- background reduction
- double excitation of sample by both the primary and the reflected beam
- very short distance sample - detector (~3mm): large solid angle

Analytical features:

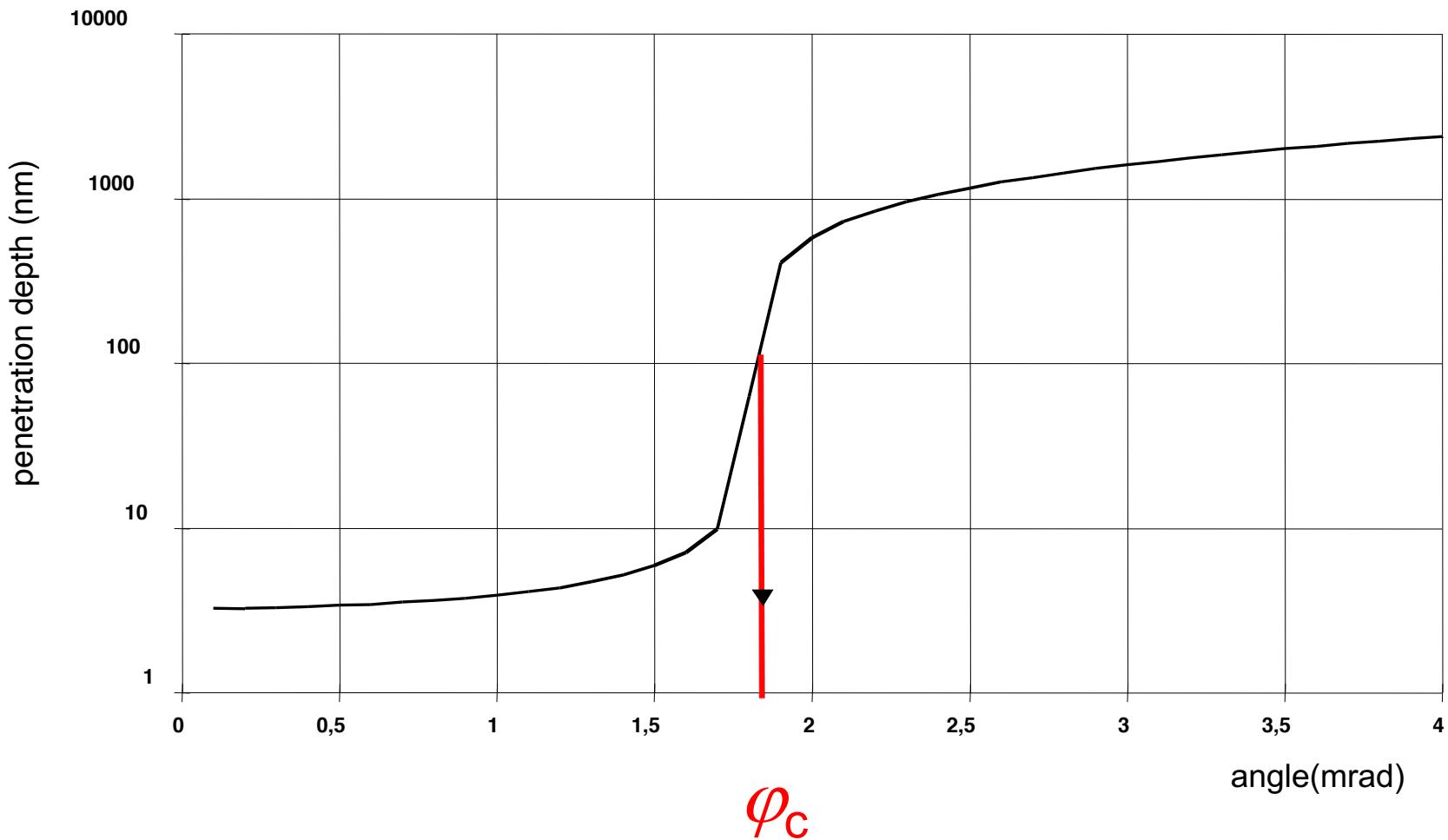
- small sample amounts required (ng, some µl)
- detection limits in the pg (ppb) range with X-ray tube excitation
- simple quantification (thin film approximation) by adding an internal standard
- angle dependence of fluorescence signal : particle – film - implants

- 3 important quantities characterize total reflection:
 - The **reflectivity R** , which increases to almost 100% below the critical angle θ_c
 - The **penetration depth**, which is of only a few nanometers thickness
 - A **standing wave** field (interference zone)

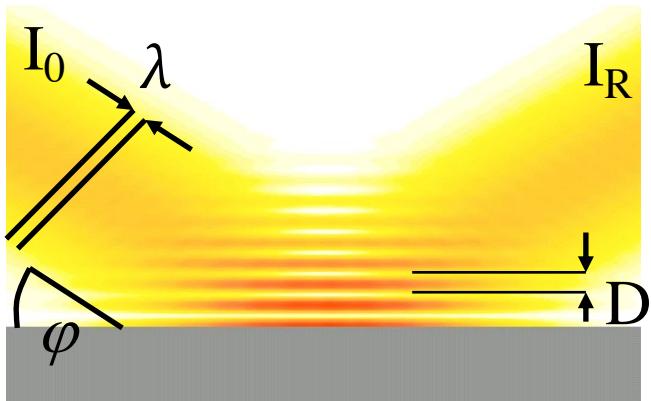


1 mrad \Rightarrow angle of 3.4 min \Rightarrow 0.057 degrees

17.5 keV in Si

 φ_c

angle(mrad)



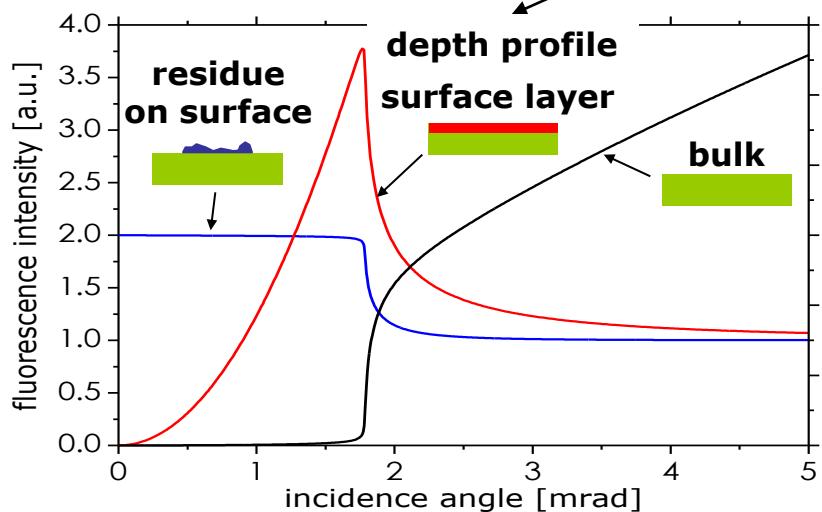
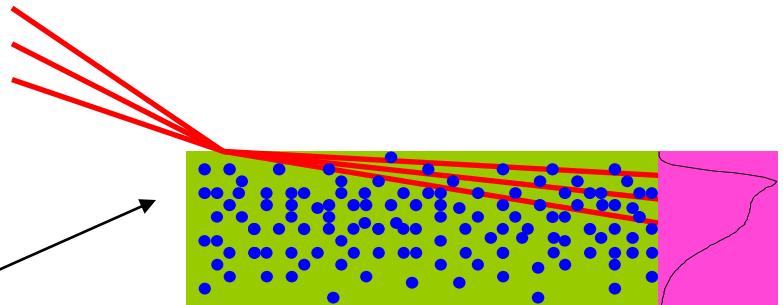
$$D = \frac{\lambda}{2 \cdot \sin \varphi} \text{ (nm range)}$$

Distance D between nodes and antinodes is a function of the incident angle.

Inside the medium, the intensity decreases exponentially as a function of the refraction angle. \Rightarrow penetration depth x_p

Angle dependence fluorescence signal \Rightarrow information sample type:

- bulk
- particle (residue on surface)
- film (surface layer)
- implants (depth profile)



The incident angle dependence of the fluorescence intensity gives information on the depth distribution of the element.

Thin-film approximation valid, if ...

A minute flat sample on the sample-carrier is practically an ideal sample:

- No sample self absorption correction
- No inter-element effect

Ideally, there is a linear relationship between the recorded X-ray intensity I_i and the concentration c_i (or mass) of an analyte:

$$I_i = S_{\text{abs}} \cdot c_i$$

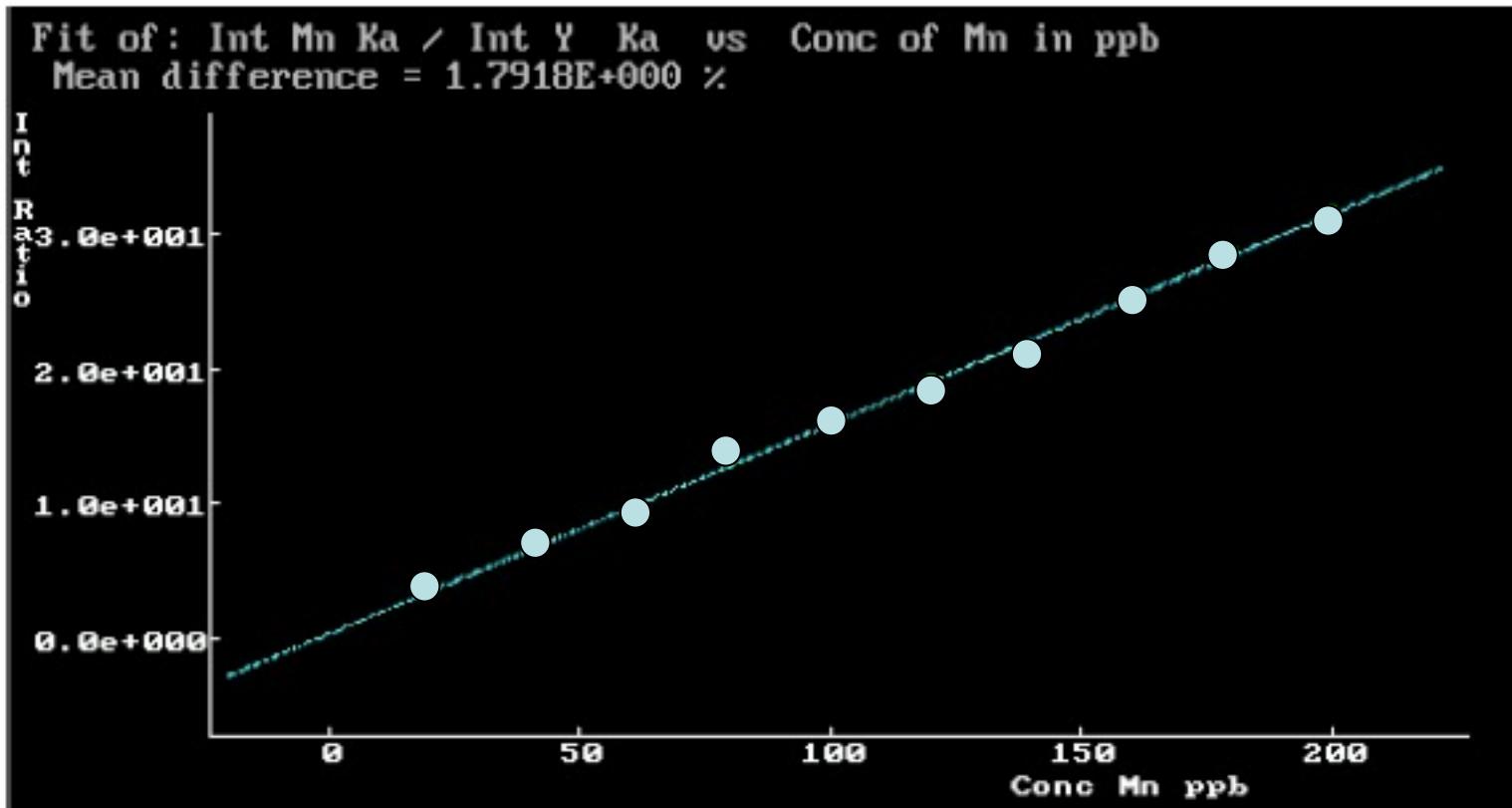
I_i net intensity of the element i

S_{abs} absolute sensitivity

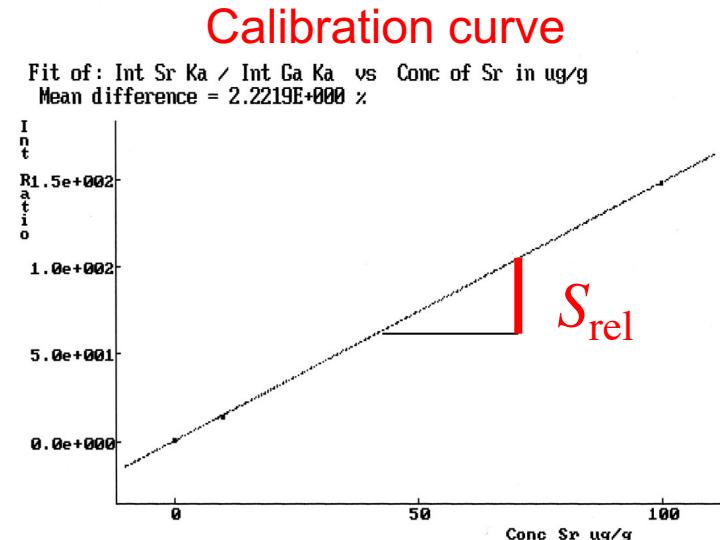
c_i concentration of i

Generally, the internal standard method is used for quantification. The same element used as internal standard is used as reference element.

The internal standard is an element initially not present in the sample. Typically, e.g. **Ga**, **Y**, or **Co** for acidic solutions, **Ge** for basic solutions.



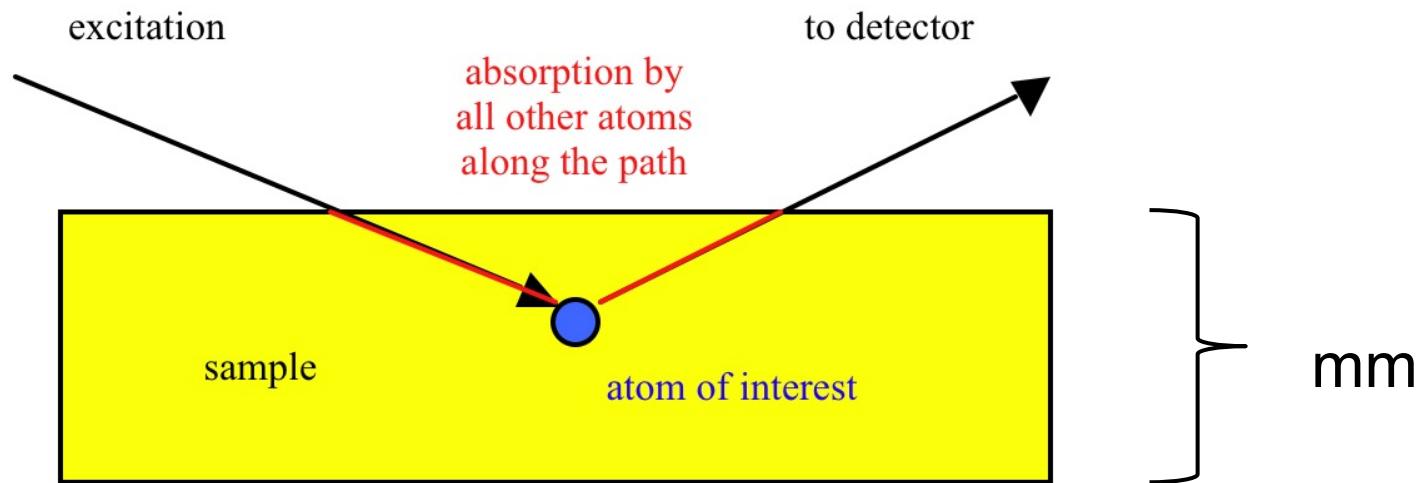
The ratios of absolute sensitivities with reference to a specific element (internal standard) are called **relative sensitivities** and can be determined by calibration.



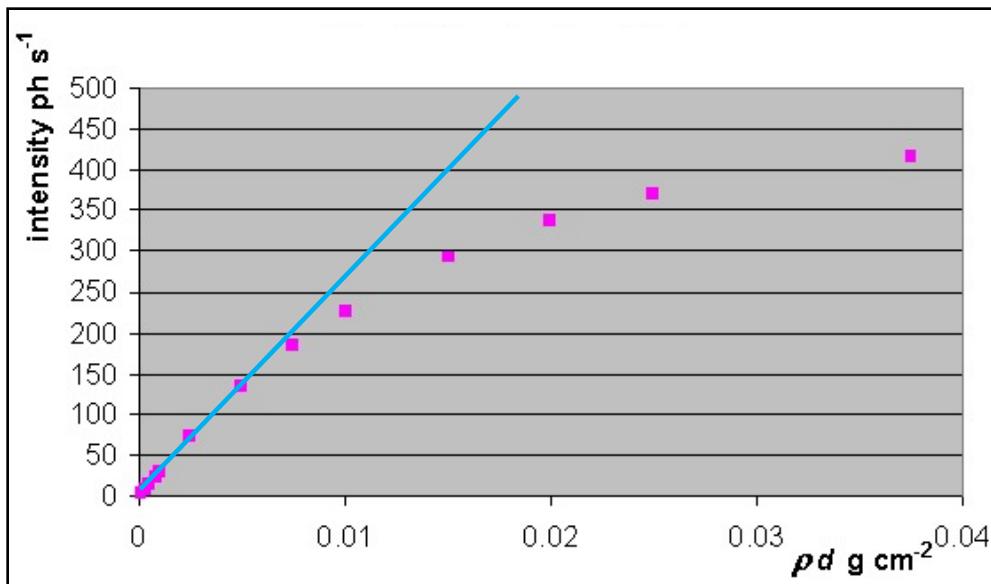
Quantification of unknown sample

$$c^i = \frac{I^i}{I^s} \cdot \frac{1}{S_{rel}^i} \cdot c^s$$

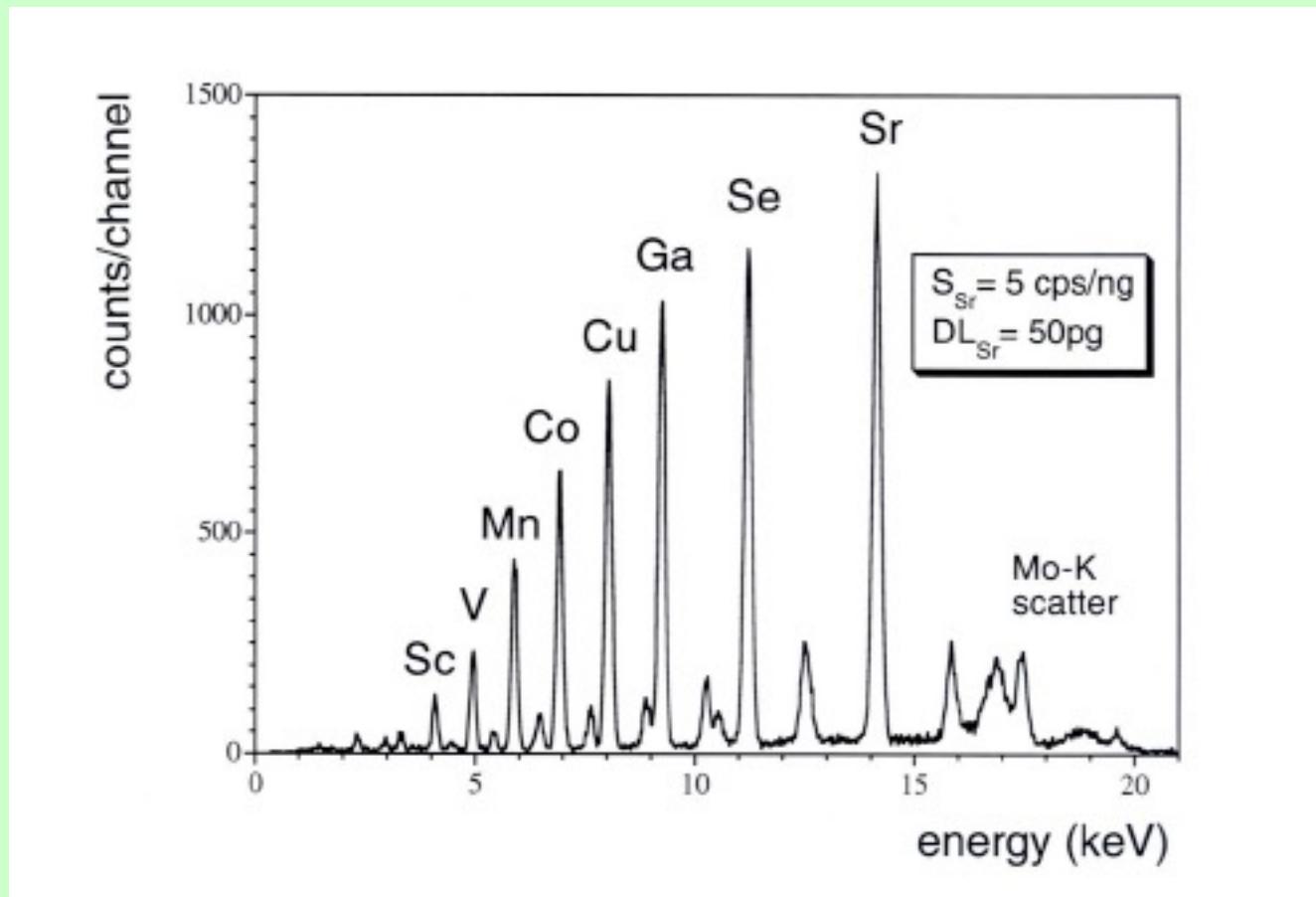
Greatest “handicap” for Quantitative XRF: Sample Self-Absorption



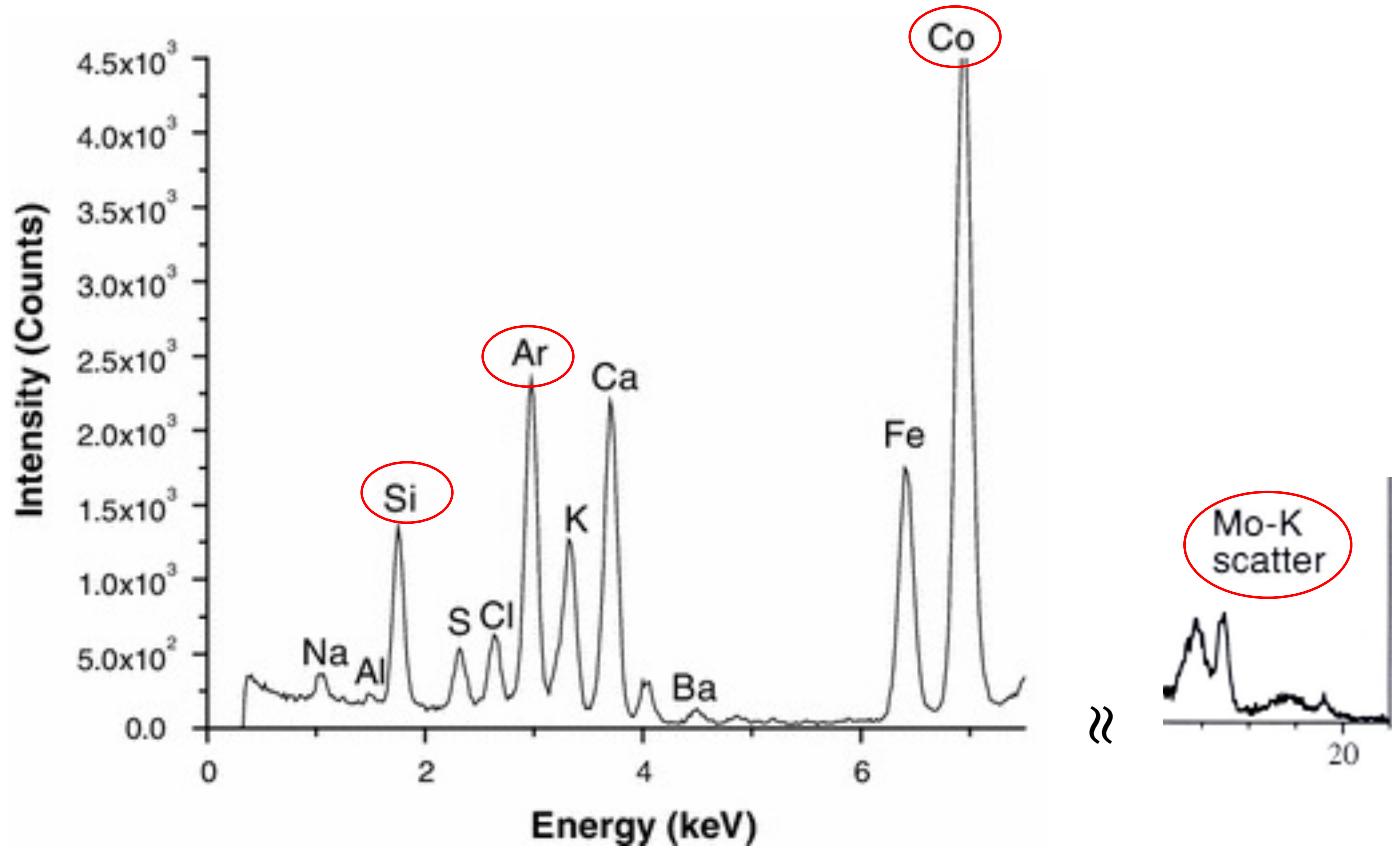
Both the exciting radiation and the fluorescence radiation of an atom (element) of interest suffer from sample self-absorption.



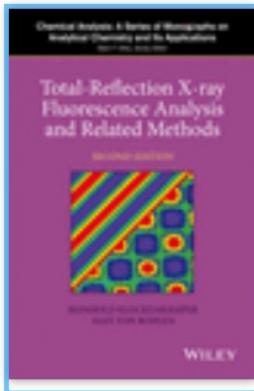
We add successive amounts to prepare synthetic samples and observe the growth in signal intensity for the elements of interest.



A typical spectrum of a calibration standard for TXRF analysis. All specified elements are present with equal amounts. Internal standard element: gallium



- TXRF is a rather universal and economical method of **multi-elemental** analysis.
- Mainly liquid samples
- It is a micro-analytical tool for small samples or **minute specimens**.
- It is being effectively applied to **trace element analysis**.
- **Detection limits** can be in the pg/ml (ppb) range.
- An **internal standard** element has to be added. Simple quantification (as compared to standard XRF), since matrix effects are absent.



Total-Reflection X-Ray Fluorescence Analysis and Related Methods

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Short and crispy:

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Diane Eichert

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